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<b>SERIAL NUMBER</b> 10/699,438	<b>FILING OR 371(c) DATE</b> 10/31/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2822	<b>ATTORNEY DOCKET NO.</b> 29936/39510
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**\*\* CONTINUING DATA \*\*\*\*\*** *MW*

**\*\* FOREIGN APPLICATIONS \*\*\*\*\*** *MW*

REPUBLIC OF KOREA 2003-62283 09/05/2003

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***

02/03/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 21	<b>TOTAL CLAIMS</b> 46	<b>INDEPENDENT CLAIMS</b> 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	Initials			

**ADDRESS**

4743

**TITLE**

Silicon wafers and method of fabricating the same

<b>FILING FEE RECEIVED</b> 1654	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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